

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Zongtao GE

Serial No.: 10/021,014

Art Unit: 2877

Filed: December 19, 2001

Examiner: TO BE ASSIGNED

For: Method of Detecting Posture of Object and Apparatus Using the Same

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97, and 1.98**

Assistant Commissioner of
Patents and Trademarks
Washington, D.C. 20231

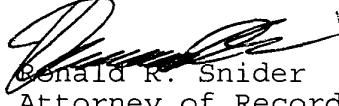
Sir:

In compliance with the dictates of 37 C.F.R. §§ 1.56, 1.97, and 1.98, Applicant hereby submits an Information Disclosure Statement.

The attached documents are mentioned in the present specification and a brief description of their relevance can be found therein.

It is respectfully requested that the Examiner consider each of these references and indicate such consideration by enclosing an appropriately initialled copy of the enclosed form PTO-1449 with the next communication from the Patent Office.

Respectfully submitted,


Ronald R. Snider
Attorney of Record
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Date: March 6, 2002

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PTO FORM 1449 SUBMISSION

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS		
Examiners Initials*	Include Author (CAPITAL LETTERS), title of article, book, magazine, etc. date, page(s), volume-issue number(s), publisher, city and/or country where published	T**
	TAKEDA, MITSUO et al., "Fourier-Transform Method, " <u>Journal of the Optical Society of America</u> , January 1982, pp. 156-158, Vol. 72, No. 1.	

Examiner Signature		Date Considered	
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***Examiner:** Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**Applicant is to place a check mark here if English language translation is attached

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